

<b>Notice of References Cited</b>	Application/Control No. 10/761,190	Applicant(s)/Patent Under Reexamination KIM, KUN-TAE	
	Examiner Jason K. Lin	Art Unit 2623	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0021998	09-2001	Margulis, Neal	725/81
*	B	US-6,704,060	03-2004	Levandowski, Mark C.	348/725
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

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